

# *The effect of second-phase particles on grain growth in thin films studied by phase field simulations*

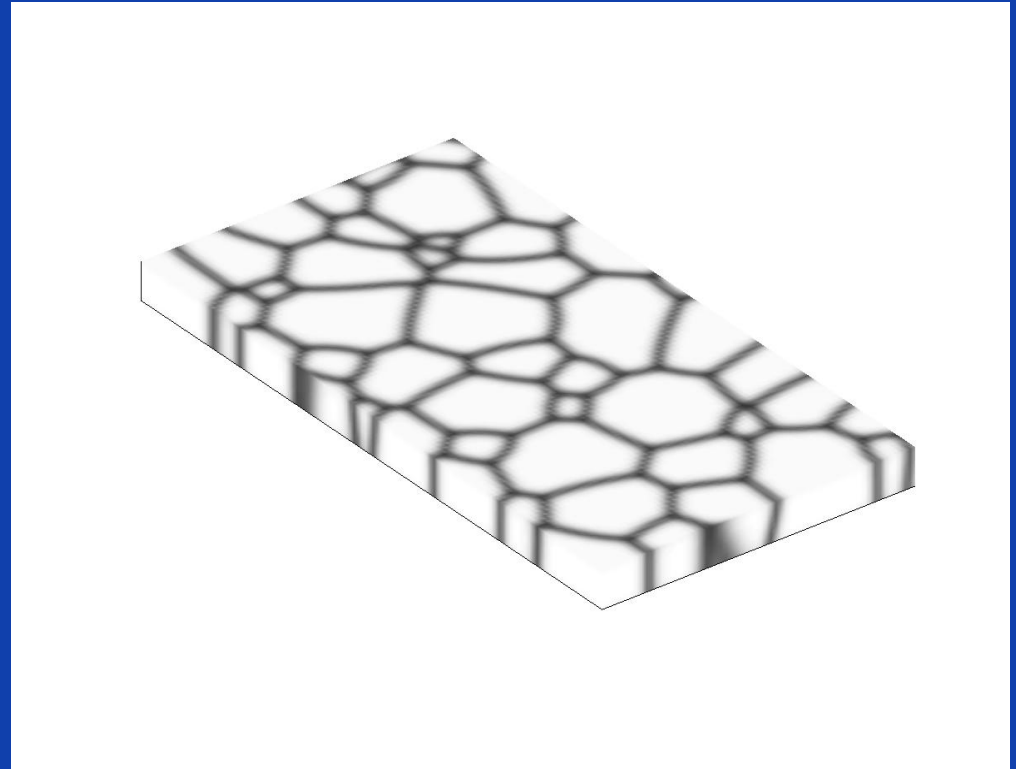
**N. Moelans, B. Blanpain, P. Wollants**

**Research group: Thermodynamics in materials engineering**

**Department of Metallurgy and Materials Engineering  
K.U. Leuven, Belgium**

- **Grain growth in thin films**
- **Zener pinning**
- **Phase field model**
- **2-D simulations**
- **3-D simulations**
- **Conclusions**

- **Bamboo structure**
  - 3-D  $\Rightarrow$  2-D grain growth
- **Surface energy**
  - Grooving
  - Anisotropy
- **Particles**



- **Pinning force of a particle**

- **3-D** :  $F_Z = 2\pi r \sigma_{gb} \cos(\beta) \sin(\beta)$

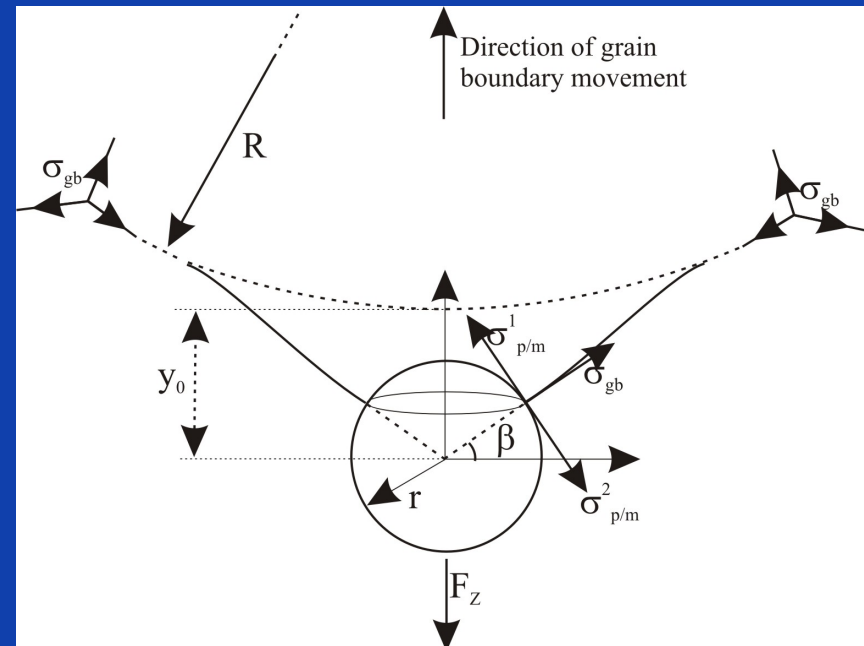
- **2-D** :  $F_Z = 2\sigma_{gb} \sin(\beta)$

- **'Dimple shape'**

- **Final grain size:**  $\frac{R_{lim}}{r} = \frac{b}{f_V^\alpha}$

- **3-D** :  $\alpha \cong 1$   
 $b = 2/3, b = 4/9, \dots$

- **2-D** :  $\alpha \cong 0.5$   
 $1.2 < b < 1.7$



- Extension of model of D. Fan and L.-Q. Chen for normal grain growth

- Phase field variables:

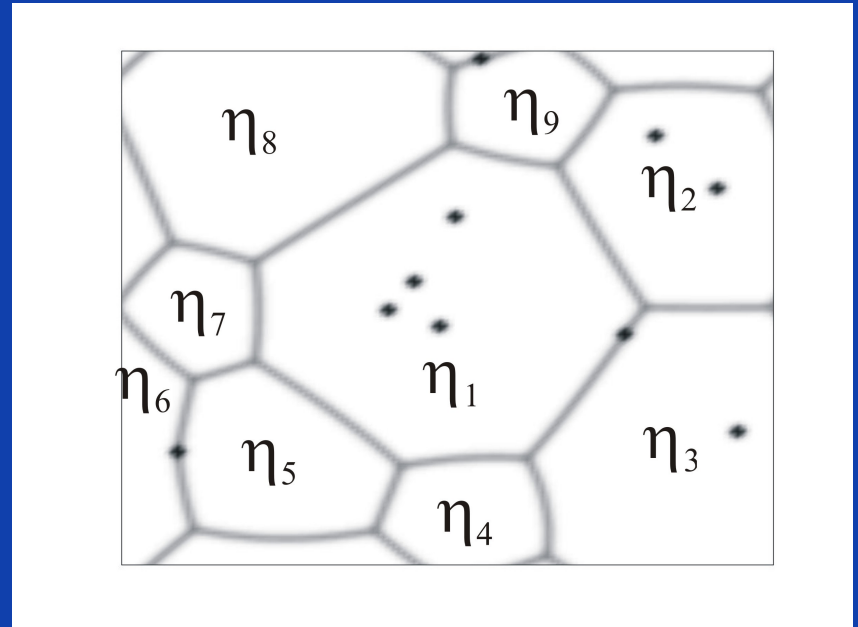
$$\eta_1, \eta_2, \dots, \eta_i, \dots, \eta_p$$

- Particles :  $\Phi=1$

$$(\eta_1, \eta_2, \dots, \eta_i, \dots, \eta_p) = (0, 0, \dots, 0, \dots, 0)$$

- Grain i of matrix-phase :  $\Phi=0$

$$(\eta_1, \eta_2, \dots, \eta_i, \dots, \eta_p) = (0, 0, \dots, 1, \dots, 0)$$



- **Free energy**

$$F = \int_V \left[ m \left( \sum_{i=1}^p \left( \frac{\eta_i^4}{4} - \frac{\eta_i^2}{2} \right) + \sum_{i=1}^p \sum_{j \neq i}^p \eta_i^2 \eta_j^2 + \varepsilon \Phi \sum_{i=1}^p \eta_i^2 \right) + \sum_{i=1}^p \frac{\kappa}{2} (\nabla \eta_i)^2 \right] dV$$

- **Equilibrium**

- $\Phi=0$  :  $(\eta_1, \eta_2, \dots, \eta_p) = (1, 0, \dots, 0), (0, 1, \dots, 0), \dots, (0, 0, \dots, 1), (-1, 0, \dots, 0), \dots$
- $\Phi=1$  :  $(\eta_1, \eta_2, \dots, \eta_p) = (0, 0, \dots, 0)$

- **Kinetic equations (Ginzburg-Landau)**

$$\frac{\partial \eta_i(\vec{r}, t)}{\partial t} = -L \frac{\partial F}{\partial \eta_i(\vec{r}, t)} = -L \left( \frac{\partial f_0(\eta_1, \eta_2, \dots)}{\partial \eta_i(\vec{r}, t)} - \kappa \nabla^2 \eta_i(\vec{r}, t) \right)$$

$$\frac{\partial \eta_i(\vec{r}, t)}{\partial t} = -L \left( \frac{\partial f(\eta_1, \eta_2, \dots)}{\partial \eta_i(\vec{r}, t)} - \kappa \nabla^2 \eta_i(\vec{r}, t) \right) \quad \text{with} \quad f = m \left( \sum_{i=1}^p \left( \frac{\eta_i^4}{4} - \frac{\eta_i^2}{2} \right) + \sum_{i=1}^p \sum_{j \neq i}^p \eta_i^2 \eta_j^2 + \epsilon \Phi \sum_{i=1}^p \eta_i^2 \right)$$

- **Grain boundary energy** :  $0.39\sqrt{\kappa m}$
- **Interfacial thickness** :  $\propto \sqrt{\frac{\kappa}{m}}$
- **Grain boundary velocity** :  $V = \kappa L(\lambda_1 + \lambda_2)$ 
  - $\Rightarrow \kappa L = M^* = M \sigma_{gb}$  (reduced mobility)
- **Interfacial energy particles** :  $f(\epsilon)\sqrt{\kappa m}$

- Parameters

$$\kappa = 0.5, L = 1, m = 1, \varepsilon = 1$$

- Particle size

- Final grain size :  $\overline{R}_{\text{lim}} = \left( \frac{b}{f_a^\alpha} \right) r$

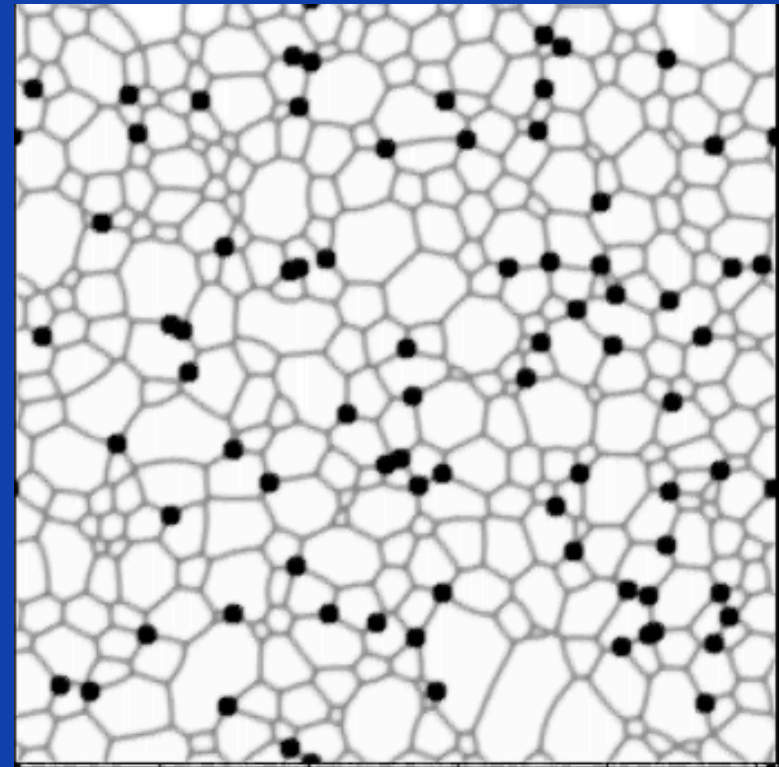
- Diffuse interfaces

- Numerical solution

- Semi-implicit fourier spectral method

- Initial microstructure

- $R_0 = 0$
- $R_0 > 0$



$$r = 3, f_a = 0.04, \overline{R}_0 = 0$$

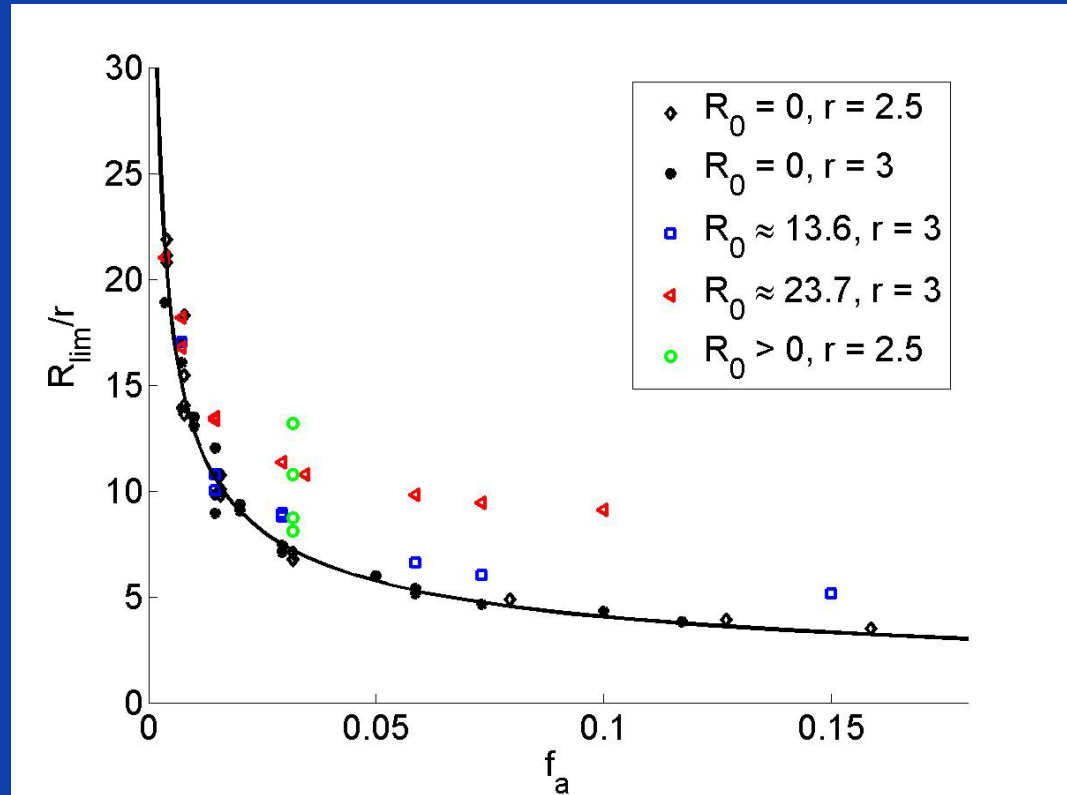
- $R_0 = 0$

$$\frac{\overline{R_{lim}}}{r} = \frac{1.28}{f_a^{0.5}}$$

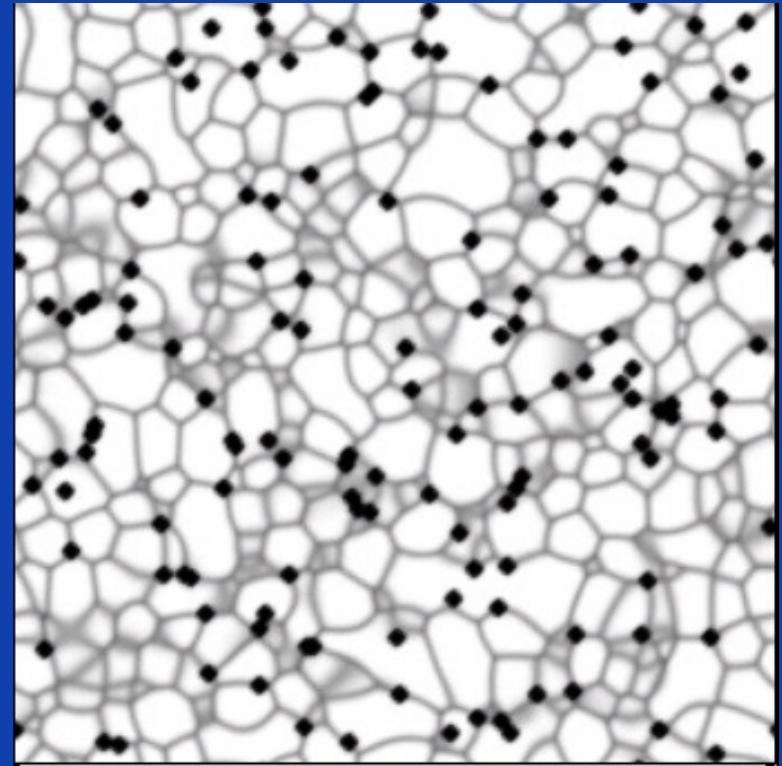
- $R_0 > 0$

For high  $f_a$ , large  $R_0$

$$\overline{R_{lim}} \cong \overline{R_0}$$

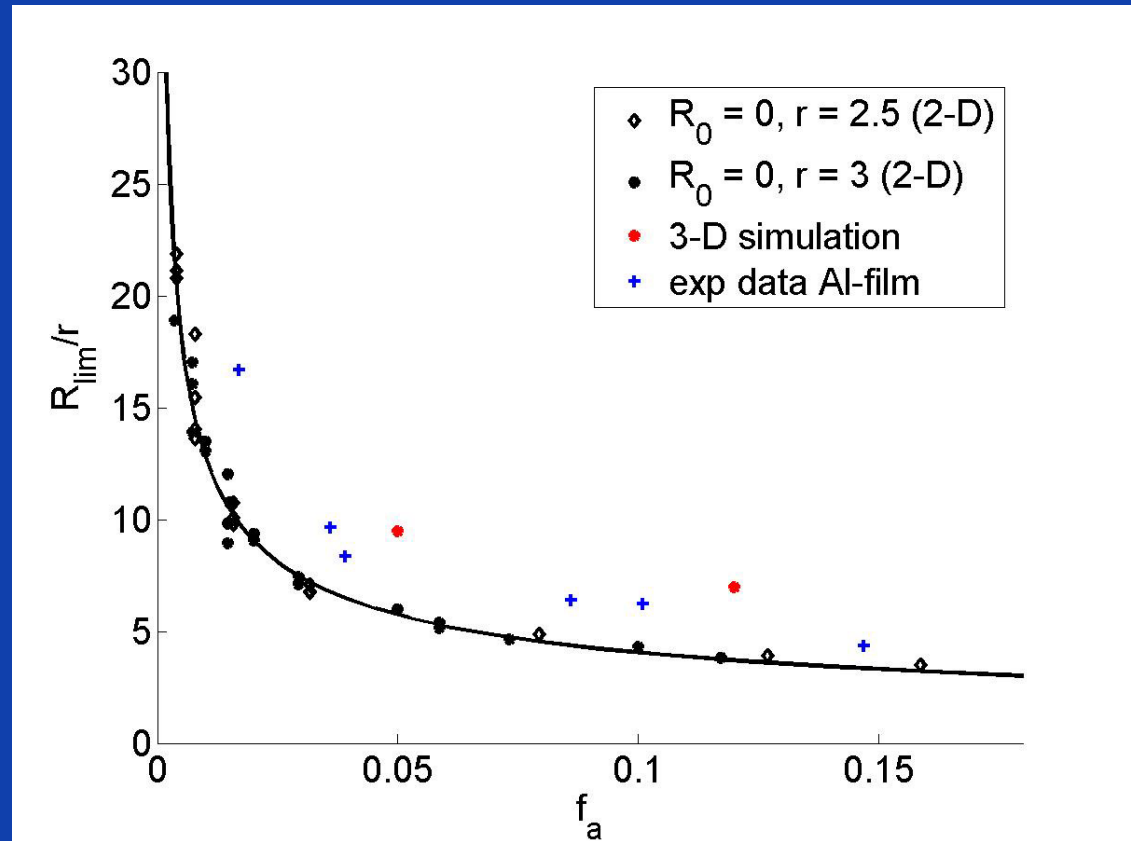


- Numerical solution
  - // film
    - 2-D Fourier spectral method
  - $\perp$  film
    - Finite differences
      - Dirichlet : drag effect
      - Neumann
- 3-D effect
  - Position of particles
  - Film thickness



$$r = 3, f_a = 0.05, l = 21$$

- **Thin Al-films**
  - **Bamboo-structure**
  - **CuAl<sub>2</sub>-particles in middle of film**
  - **$r \cong 1/7$  film thickness**



*Data from H.P. Longworth and C.V. Thompson*

- **2-D and 3-D phase field simulations of grain growth in thin films containing second-phase particles were performed**
- **2-D simulations => importance of  $R_0$**
- **3-D simulations => particles introduce 3-D effect**
- **Important parameters**
  - **Ratio of particle size and film thickness**
  - **Position of particles**

**Thank you for your attention !**

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